

INVENTOR INFORMATION

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CORRESPONDENCE INFORMATION

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APPLICATION INFORMATION

Title Line One:: METHOD OF MANUFACTURING A SEMICONDUCTOR
Title Line Two:: DEVICE
Total Drawing Sheets:: 17
Formal Drawings?: Yes
Application Type:: Utility
Docket Number:: 740756-2406
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22204
Registration Number One:: 38285
Registration Number Two:: 35483
Registration Number Three:: 45285
Registration Number Four:: 26477
Registration Number Five:: 28290

CONTINUITY INFORMATION

This application is a:: DIVISION OF

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Foreign Application One:: 09-308043
Filing Date:: 10-21-1997
Country:: Japan
Priority Claimed:: Yes
Foreign Application Two:: 10-152305
Filing Date:: 05-16-1998
Country:: Japan
Priority Claimed:: Yes
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